

**REQUEST
FOR
CONTINUED EXAMINATION (RCE)
TRANSMITTAL**

Subsection (b) of 35 U.S.C. § 132, effective on May 29, 2000,
provides for continued examination of an utility or plant application
filed on or after June 8, 1995.
See The American Inventors Protection Act of 1999 (AIPA).

<i>Application Number</i>	09/858,337
<i>Filing Date</i>	May 15, 2001
<i>First Named Inventor</i>	William J. Schaff
<i>Confirmation Number</i>	1100
<i>Group Art Unit</i>	2822
<i>Examiner Name</i>	Khanh Duong
<i>Attorney Docket Number</i>	1153.044US1
<i>Customer No.</i>	21186

This is a Request for Continued Examination (RCE) under 37 C.F.R. § 1.114 of the above-identified application
entitled
AIN COATED HETEROJUNCTION FIELD EFFECT TRANSISTOR AND METHOD OF FORMING AN AIN
COATING

1. Submission required under 37 C.F.R. § 1.114:

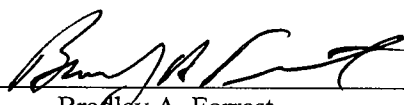
☒ Amendment and Response with Request to Reopen Prosecution (8 pages) is enclosed.

2. Fees

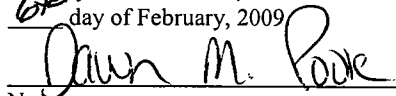
☒ Authorization to charge deposit account 19-0743 in the amount of \$405.00 to pay the RCE filing fee required
under 37 C.F.R. § 1.17(e).

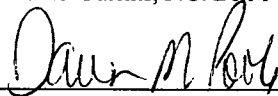
☒ **The Commissioner is hereby authorized to charge any additional fees or credit overpayment to Deposit
Account No. 19-0743.**

SCHWEGMAN, LUNDBERG & WOESSNER, P.A.

By: 
Bradley A. Forrest
Reg. No. 30,837

CERTIFICATE UNDER 37 C.F.R. 1.8: The undersigned hereby certifies that this correspondence is being filed using the USPTO's electronic
filing system EFS-Web, and is addressed to: Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on this
6th day of February, 2009


Name


Signature